

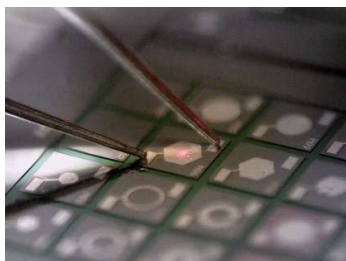


UNIVERSITY OF ZAGREB
Faculty of Electrical
Engineering and
Computing



Financira
Europska unija
NextGenerationEU

Projektna radionica: Elektronički senzorski sustavi s niskom potrošnjom energije za detekciju akustičkih događaja



NPOO.C3.2.R2-I1.06.0090

<https://www.fer.unizg.hr/liss/aemems>

Sveučilište u Zagrebu

Fakultet elektrotehnike i računarstva

Petak, 22.05.2026. 09:00 - 14:00 h, Siva vijećnica

09:00 - 09:10	Registracija sudionika
09:10 - 09:30	Uvodna riječ, ciljevi, aktivnosti i rezultati projekta voditelj projekta, izv. prof. dr. sc. Dinko Oletić Sveučilište u Zagrebu Fakultet elektrotehnike i računarstva
09:30 - 09:50	Development of a custom MEMS technological process on SOI wafers with ZnO thin-film piezoelectric Prof. dr. sc. Emile Martincic i dr. sc. Etienne Herth C2N, Universite Paris-Saclay
09:50 - 10:10	Designing MEMS-based ultrasonic acoustic emission NDT sensors with built-in frequency-decomposition capability Mihael Katalenić, mag. ing. Sveučilište u Zagrebu Fakultet elektrotehnike i računarstva
10:10 - 10:30	Pauza za kavu
10:30 - 10:50	Development of a novel MEMS technological process on SOI wafers with AlN thin-film piezoelectric Peter Fecko i Linda Supalova CEITEC Nano, Brno University of Technology
10:50 - 11:10	Design of PMUT receiver elements for biomedical photoacoustic ultrasonic imaging applications Niko Plantak, mag. ing. Sveučilište u Zagrebu Fakultet elektrotehnike i računarstva
11:10 - 11:30	Integrated multichannel analog sensor frontends in TSMC 65 nm for piezoelectric ultrasonic MEMS sensors Dr. sc. Edi Emanović Sveučilište u Zagrebu Fakultet elektrotehnike i računarstva
11:30 - 11:50	Integrated digital interfaces in TSMC 65 nm for recording, feature extraction, and readout of ultrasonic MEMS sensors Doc. dr. sc. Jurica Kandrata Sveučilište u Zagrebu Fakultet elektrotehnike i računarstva
12:00 - 13:00	Umrežavanje i ručak
13:00 - 14:00	Posjeta laboratorija